D STATES PATENT AND TRADEMARK OFFICE

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In re application of: Norikazu MIZUNO et al.

Serial No: 09/670 917 Filed: September 29, 2000

SEMICONDUCTOR DEVICE MANUFACTURING METHOD AND APPARATUS FOR REMOVING SILICON NITRIDE FORMED IN A REACTION CONTAINER (As Amended)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sin

Transmitted herewith is an amendment in the above-identified application.

Small entity status has been claimed. See 37 CFR § 1.27.

A Notice Of Change Of Attorney's Address and Associate Power Of Attorney is enclosed. No additional fee is required.

The fee has been calculated as shown belo

I hereby certify that this correspondence is being deposited with the United States Posta Sentos with sufficient postage as first class mail in an envelope addressed to:						
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450, on December 4, 2003						
Dod of Deposit Application Che Reg. No. 41,232 12/04/03 Signature Date						

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUME PREVIOUSLY PAID		PRESENT EXTRA*	LG/SM \$ ENTITY FEE		ADO'L FEE OUE	
TOTAL CLAIMS FEE	19	1.1	20	-	0	LG=\$18 SM=\$9	\$18	5	0
INDEPENDENT CLAIMS FEE	4	H	3		1	LG=\$86 SM=\$43	\$86	\$	86
FIRST PRESENTATION OF MULTIPLE DEPENDENT CLAIMS LARGE ENTITY FEE = \$290 SMALL ENTITY FEE = \$145									0
							TOTAL	3	0

If the entry in Cd. 1 is less than the entry in Cd. 2, write '0' in Cd. 3.

If the "Highest Number Previously Pad Far' In THIS SPACE is less than 20, write "20" in this space.

If the "Highest Number Previously Pad Far' In THIS SPACE is less than 20, write "2" in this space. The "Highest Number Previously Pad For' (Total or independent) is the highest number found from the equivalent box on Col. 1 of a prior amendment or the number of claims originally fled

A check in the amount of \$ -0- to cover the additional claims fee is enclosed. A copy of this sheet is A check in the amount of \$ -0- to cover the extension fee is enclosed. A copy of this sheet is enclosed.

The Commissioner is hereby authorized to charge any deficiencies of fees associated with this communication or credit any overpayment to Deposit Account No. 50-1314. A copy of this sheet is Any filing fees under 37 C.F.R. § 1.16 for the presentation of extra claims

Date: December 4, 2003

Biltmore Tower 500 South Grand Avenue, Suite 1900 Los Angeles, California 90071 Telephone: 213 337-6700 Facsimile: 213 337-6701

Any patent application processing fees under 37 C.F.R. § 1.17 HOGAN CHARTS nony J. Or Registration No. 41 232 Attorney for Applicant(s) Application No. 09/670,917 Reply to Office Action of June 4 2003 Amendment Dated: December 4, 2003 Attorney Docket No. 81877.0007



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Norikazu MIZUNO et al.

Serial No: 09/670.917

Filed: September 29, 2000 Confirmation No. 1895

AMENDED)

For:

SEMICONDUCTOR DEVICE MANUFACTURING METHOD AND APPARATUS FOR REMOVING SILICON NITRIDE FORMED IN A REACTION CONTAINER (AS

AMENDMENT

Commissioner for Patents P.O. Box 1450

Door Sir-

Alexandria, VA 22313-1450

In response to the Office Action dated June 4, 2003, the time for response which is extended by three months by the accompanying petition from September 4, 2003 to December 4, 2003, please amend the above-referenced application as follows:

Amendments to the Claims are reflected in the listing of the claims, which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

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Art Unit: 2822

Examiner: Maria R. Guerrero

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